

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : CHOI et al.  
Serial No. : 10/592,971(U.S. Publication No: 2008-0245961)  
Filing Date : 15 September 2006  
For : NANOWIRE ASSISTED LASER DESORPTION/IONIZATION  
MASS SPECTROMETRIC ANALYSIS  
Examiner : CHANG, Hanway  
Art Unit : 2881

745 Fifth Avenue  
New York, NY 10151

**AMENDMENT AFTER NON-FINAL REJECTION**

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the 6 March 2009 Office Action, setting a three month term for reply. The Commissioner is hereby authorized to charge any additional fee which may be required, or credit any overpayment to Account No. 50-0320.